



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Appl. No. : 09/927,428 Confirmation No.: 6387
Applicant : YUN, WENBING ET AL.
Title : METHOD FOR NANOMACHINING HIGH ASPECT RATIO
STRUCTURES
Filed : 08/09/2001
TC/A.U. : 1765
Examiner : DEO, DUY VU NGUYEN
Docket No. : LBL-IB-1498
Cust. No. : 8156

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JAN 29 2004
TC 1700

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22213-1450

AMENDMENT

Dear Sir:

In response to the Office Action mailed 07/22/2003 (paper number 12), please amend the above-identified U.S. patent application as follows:

Amendments to the Specification begin on page 2 of this paper.

Amendments to the Claims are reflected in the listing of claims which begins on page 4 of this paper.

Remarks/Arguments begin on page 24 of this paper.

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01 FC:2201 215.00 OP
02 FC:2202 387.00 OP